

Electronic Patent Application Fee Transmittal

Application Number:	10519699
Filing Date:	14-Sep-2005
Title of Invention:	Ion implantation device and a method of semiconductor manufacturing by the implantation of boron hydride cluster ions
First Named Inventor/Applicant Name:	Thomas N. Horsky
Filer:	John S. Paniaguas/Anna Franz
Attorney Docket Number:	211843-00032

Filed as Large Entity

U.S. National Stage under 35 USC 371 Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 2 months with \$0 paid	1252	1	490	490

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				490